

<b>Notice of References Cited</b>	Application/Control No. 10/565,430		Applicant(s)/Patent Under Reexamination OKAMOTO ET AL.	
	Examiner HUI CHIN		Art Unit 1796	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0125450	07-2003	Fujisawa et al.	524/502
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2005008817 A	01-2005	Japan	OKAMOTO et al.	C08L 09/00
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Translation of JP2005008817, January 2005.
	V	
	W	
	X	

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